

FIG. 3A

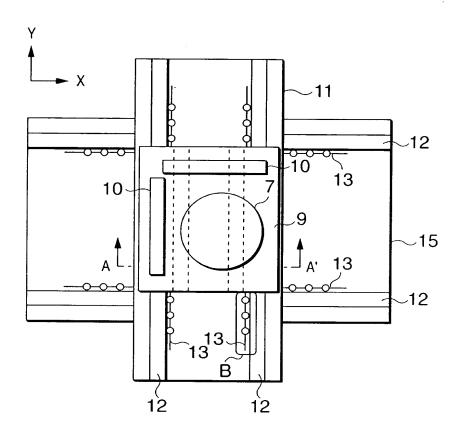
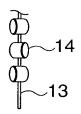


FIG. 3B

12 12 12 14

SECTIONAL VIEW TAKEN ALONG LINE A - A'

FIG. 3C



ENLARGED VIEW OF PORTION B

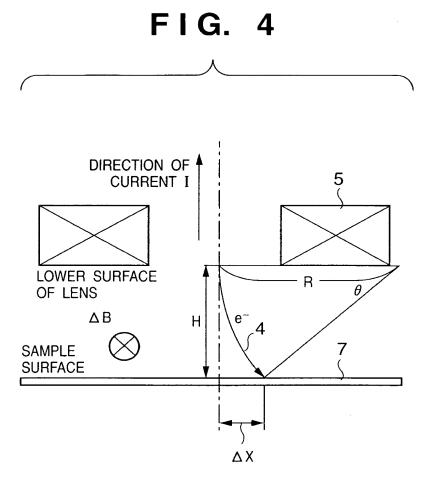
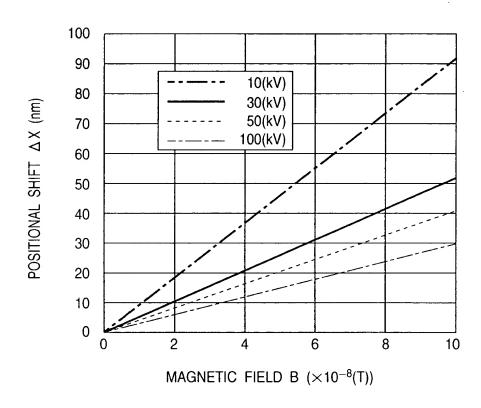


FIG. 5



RELATIONSHIP BETWEEN POSITIONAL SHIFT OF ELECTRON BEAM AND MAGNETIC FIELD CHANGE AMOUNT $(H=25(mm),\ E=10,30,50,100(kV))$

FIG. 6A

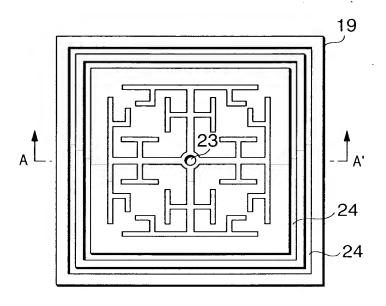
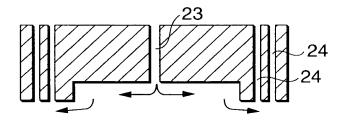


FIG. 6B



SECTIONAL VIEW TAKEN ALONG LINE A - A'

FIG. 7A

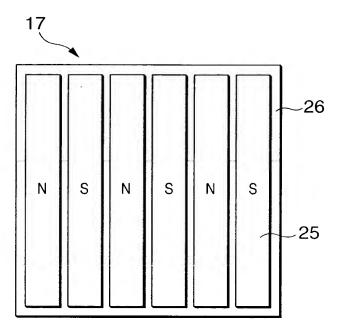
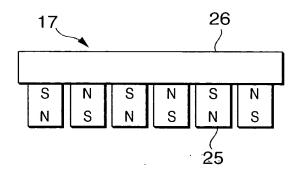


FIG. 7B



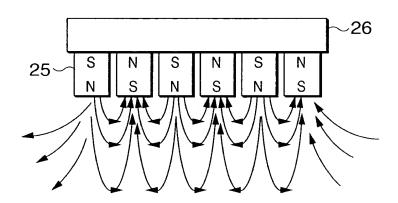
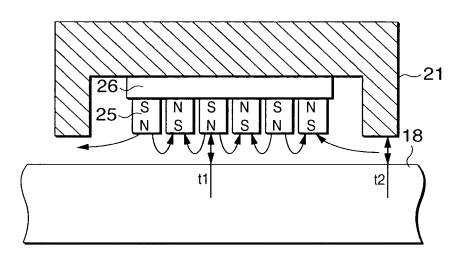
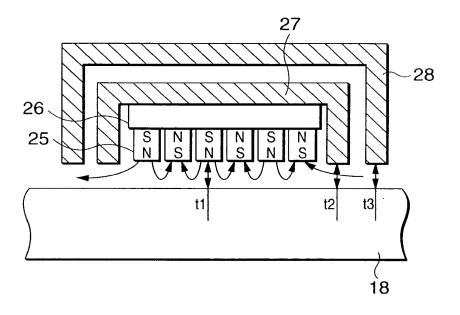
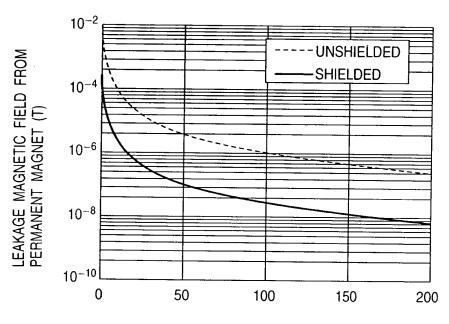


FIG. 9

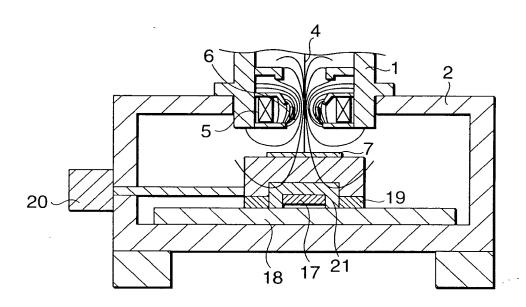






DISTANCE FROM PERMANENT MAGNET (mm)

EXTERNAL MAGNETIC FIELD SHIELD EFFECT OF PERMANENT MAGNET



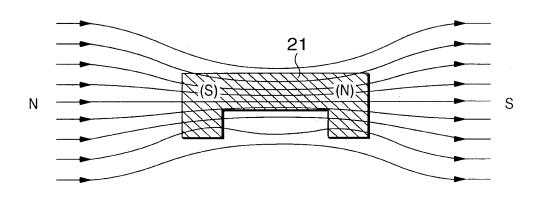
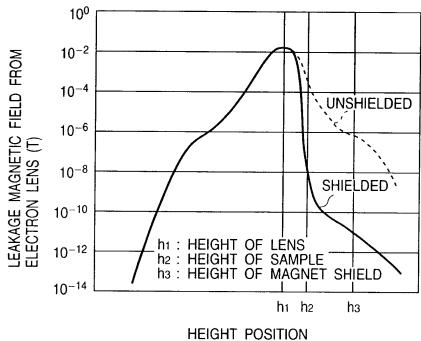
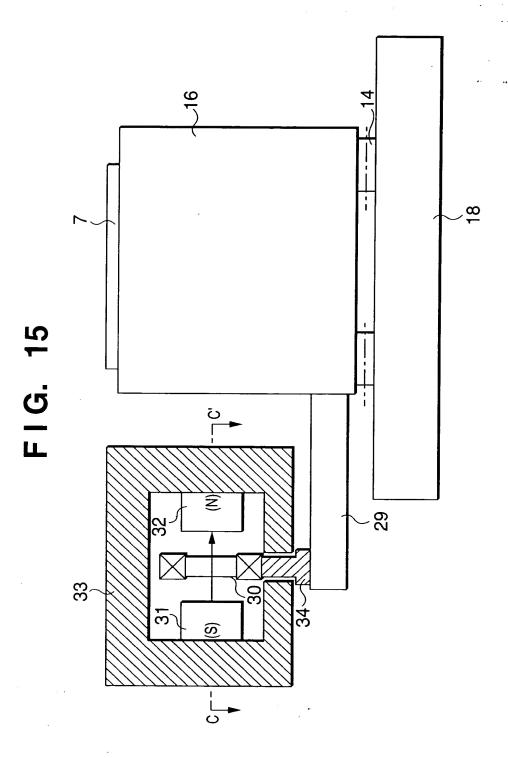
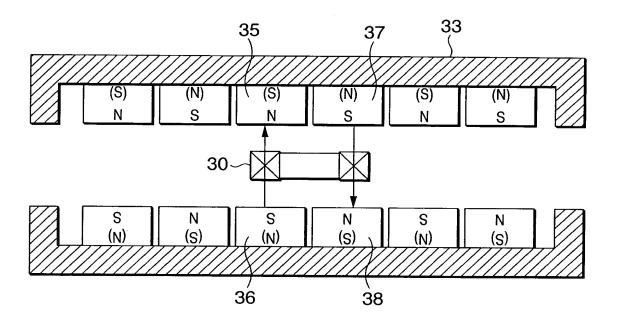


FIG.



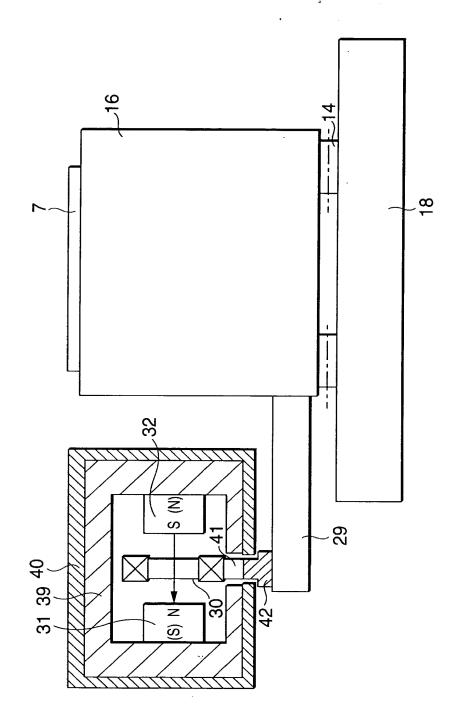
SHIELD EFFECT FOR ELECTRON LENS LEAKAGE MAGNETIC FIELD





CROSS-SECTIONAL VIEW TAKEN ALONG LINE C - C'

FIG. 17



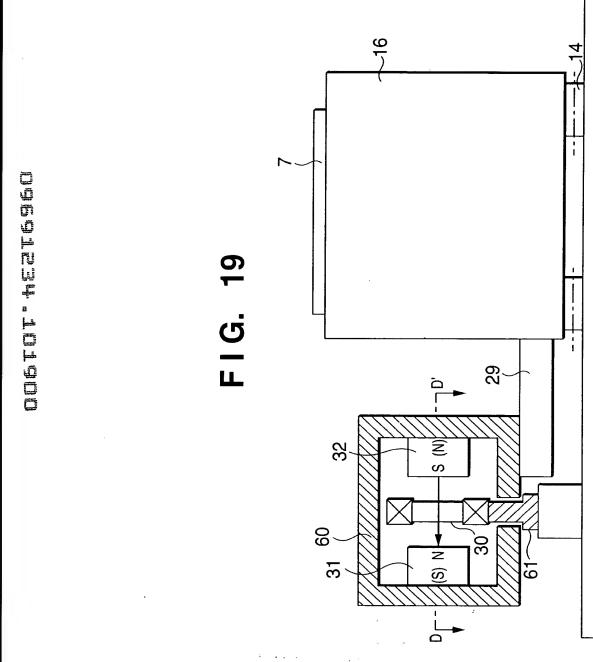
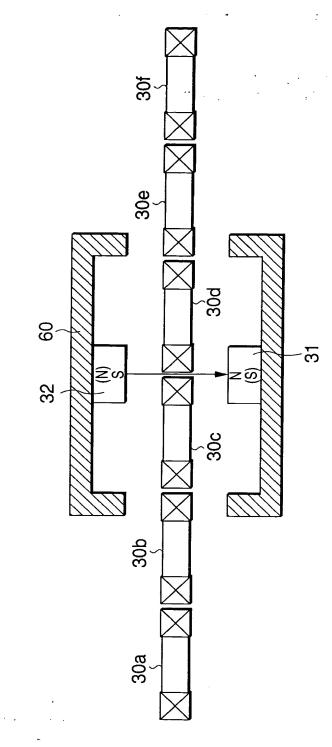


FIG. 20



CROSS-SECTIONAL VIEW TAKEN ALONG LINE D - D'

21/26

FIG. 21A

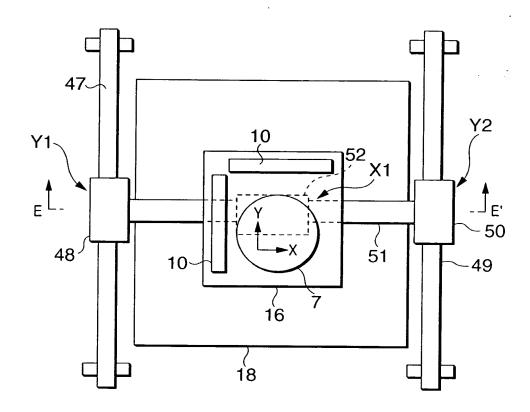
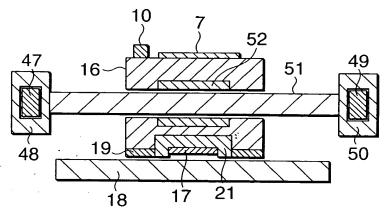


FIG. 21B



SECTIONAL VIEW TAKEN ALONG LINE E - E'

FIG. 22

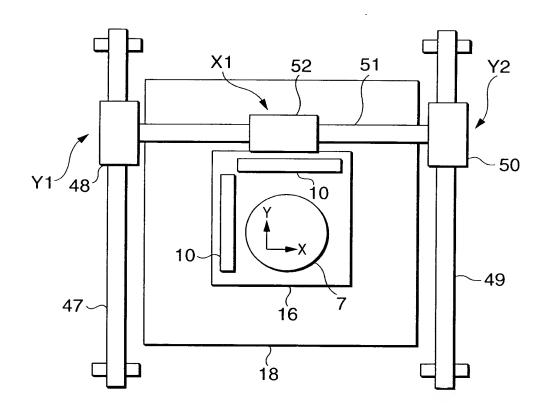


FIG. 23

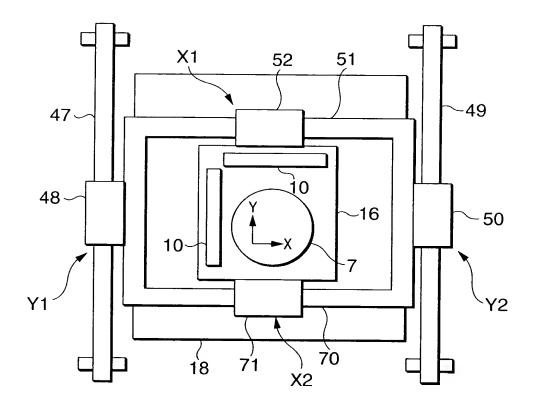


FIG. 24A

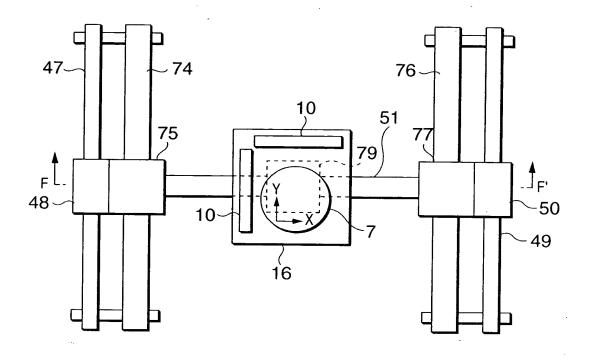
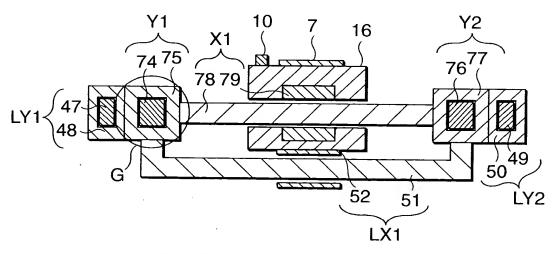
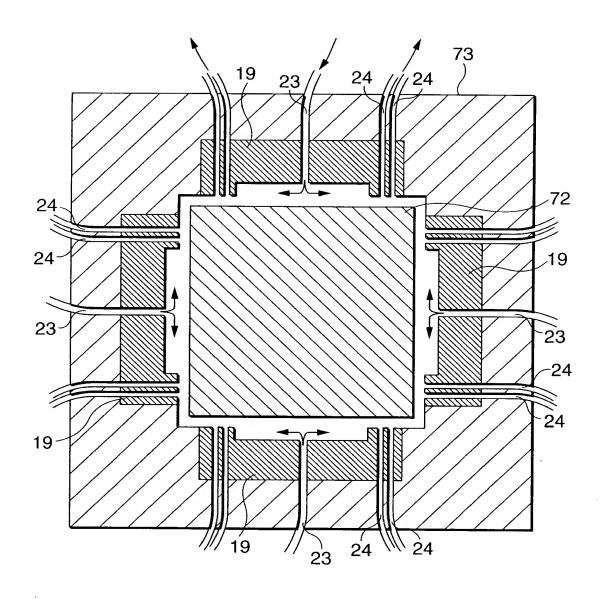


FIG. 24B



SECTIONAL VIEW TAKEN ALONG LINE F - F'



ENLARGED VIEW OF PORTION G IN FIG.24B

FIG. 26A

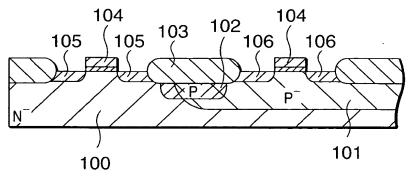


FIG. 26B

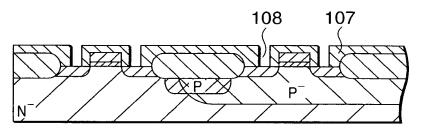


FIG. 26C

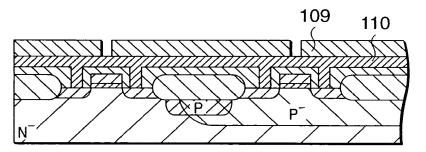
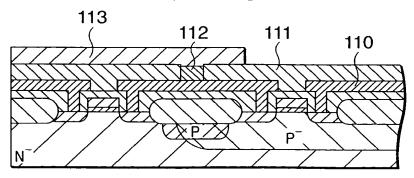


FIG. 26D



DOCTEST LOTODO